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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/577,057	04/24/2006	Yohei Kanno	740756-2956	9926
22204	7590	04/01/2009	EXAMINER	
NIXON PEABODY, LLP 401 9TH STREET, NW SUITE 900 WASHINGTON, DC 20004-2128				WARREN, MATTHEW E
ART UNIT		PAPER NUMBER		
2815				
			MAIL DATE	DELIVERY MODE
			04/01/2009	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

<b>Office Action Summary</b>	<b>Application No.</b>	<b>Applicant(s)</b>	
	10/577,057	KANNO ET AL.	
	<b>Examiner</b>	<b>Art Unit</b>	
	MATTHEW E. WARREN	2815	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

#### Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

#### Status

- 1) Responsive to communication(s) filed on 14 January 2009.  
 2a) This action is **FINAL**.                    2b) This action is non-final.  
 3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

#### Disposition of Claims

- 4) Claim(s) 1-6 and 13-18 is/are pending in the application.  
 4a) Of the above claim(s) \_\_\_\_\_ is/are withdrawn from consideration.  
 5) Claim(s) \_\_\_\_\_ is/are allowed.  
 6) Claim(s) 1-6 and 13-18 is/are rejected.  
 7) Claim(s) \_\_\_\_\_ is/are objected to.  
 8) Claim(s) \_\_\_\_\_ are subject to restriction and/or election requirement.

#### Application Papers

- 9) The specification is objected to by the Examiner.  
 10) The drawing(s) filed on 4-24-06 is/are: a) accepted or b) objected to by the Examiner.  
 Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  
 Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).  
 11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

#### Priority under 35 U.S.C. § 119

- 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  
 a) All    b) Some \* c) None of:  
 1. Certified copies of the priority documents have been received.  
 2. Certified copies of the priority documents have been received in Application No. \_\_\_\_\_.  
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

\* See the attached detailed Office action for a list of the certified copies not received.

#### Attachment(s)

- |  |   |
|--|---|
| 1) <input checked="" type="checkbox"/> Notice of References Cited (PTO-892)            | 4) <input type="checkbox"/> Interview Summary (PTO-413)           |
| 2) <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948)   | Paper No(s)/Mail Date. _____ .                                    |
| 3) <input checked="" type="checkbox"/> Information Disclosure Statement(s) (PTO/SB/08) | 5) <input type="checkbox"/> Notice of Informal Patent Application |
| Paper No(s)/Mail Date <u>1/16/09, 3/5/09</u> .   | 6) <input type="checkbox"/> Other: _____ .                        |

## DETAILED ACTION

This Office Action is in response to the RCE and Amendment filed on January 14, 2009.

### ***Claim Rejections - 35 USC § 112***

Claims 3-16 and 15-18 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention. Claims 3 and 14 recite the limitations “ . . . wherein a thickness of a portion of the semiconductor film over which the insulating film is formed is thinner than that of the other semiconductor film, and the semiconductor film over which the insulating film is formed has a thickness of 10 nm or more.” The grammatical structure of the limitations in question makes it difficult to determine if the semiconductor film is over the insulating film or under the insulating film.

Also the limitation of "the other semiconductor film lacks sufficient antecedent basis. The limitation makes it seem as if there is a second semiconductor film.

For these reasons, the claims limitations in question will be ignored and interpreted as follows:

“ . . . wherein a thickness of a portion of the semiconductor film over which the insulating film is formed is thinner than that of the other semiconductor film, and the semiconductor film over which the insulating film is formed has a thickness of 10 nm or more.”

***Claim Rejections - 35 USC § 102***

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless –

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-4 and 6 are rejected under 35 U.S.C. 102(b) as being anticipated by Wei et al. (US 5,156,986).

In re claim 1, Wei et al. shows (fig. ) a semiconductor element comprising: a layer comprising titanium (14) formed over a substrate (12); a gate electrode layer (16) formed over the layer comprising titanium; a gate insulating film (28) formed in contact with a top surface of the gate electrode layer and a top surface of the layer comprising titanium; a semiconductor film (30) formed over the gate insulating film; a pair of n-type impurity regions (32) formed over the semiconductor film; an insulating film (48) that is interposed between the pair of n-type impurity regions and that is formed over the semiconductor film; and a conductive layer (34, 36) formed over the pair of n-type impurity regions.

In re claim 2, Wei et al. shows (fig. ) a semiconductor element comprising: a layer comprising titanium (14) formed over a substrate (12); a gate electrode layer (16) formed over the layer comprising titanium; a gate insulating film (28) formed in contact with a top surface of the gate electrode layer and a top surface of the layer comprising titanium; a semiconductor film (30) formed over the gate insulating film; a pair of n-type

impurity regions (32) formed over the semiconductor film; an insulating film (48) having a thickness of 100 nm (col. 8, lines 37-46) or more (2000 Å = 200 nm > 100 nm) that is interposed between the pair of n-type impurity regions and that is formed over the semiconductor film; and a conductive layer (34, 36) formed over the pair of n-type impurity regions.

In re claim 3, as far as understood, Wei et al. shows (fig. ) a semiconductor element comprising: a layer comprising titanium (14) formed over a substrate (12); a gate electrode layer (16) formed over the layer comprising titanium; a gate insulating film (28) formed in contact with a top surface of the gate electrode layer and a top surface of the layer comprising titanium; a semiconductor film (30) formed over the gate insulating film; a pair of n-type impurity regions (32) formed over the semiconductor film; an insulating film (48) that is interposed between the pair of n-type impurity regions and that is formed over the semiconductor film; and a conductive layer (34, 36) formed over the pair of n-type impurity regions, wherein ~~a thickness of a portion of the semiconductor film over which the insulating film is formed is thinner than that of the other semiconductor film, and the semiconductor film over which the insulating film is formed has a thickness of 10 nm or more (col. 7, lines 3-11) (2000 Å = 200 nm > 10 nm).~~

In re claim 4, Wei discloses (col. 8, line 37-46) that the insulating film comprises one of the materials of the group listed in the claims which is polyimide.

In re claim 6, Wei discloses (col. 1, lines 40-49) wherein the semiconductor element is incorporated in at least one selected from the group consisting of a TV reception set, an electronic book and a cellular phone (since the TFTs of the invention are employed in an LCD display which is used in a TV, electronic book, or cell phone).

***Claim Rejections - 35 USC § 103***

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

Claim 5 is rejected under 35 U.S.C. 103(a) as being unpatentable over Wei et al. (US 5,156,986) as applied to claims 1-3 above and further in view of Sasaki et al (US 6,956,236).

In re claim 5, Wei discloses all of the limitations of the claims except the layer comprising titanium oxide. However Sasaki discloses wherein the layer comprises titanium oxide (40b Fig 1). It would have been obvious to one having ordinary skill in the art at the time the invention was made to provide the layer with the specified material, since it has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability for the intended use as a matter of obvious design choice. [In re Leshin, 125 USPQ 416].

Claims 13-18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wei et al. (US 5,156,986) in view of Sasaki et al (US 6,956,236).

In re claim 13, Wei et al. shows (fig. ) a semiconductor element comprising: a layer comprising titanium (14) formed over a substrate (12); a gate electrode layer (16) formed over the layer comprising titanium; a gate insulating film (28) formed in contact with a top surface of the gate electrode layer and a top surface of the layer comprising titanium; a semiconductor film (30) formed over the gate insulating film; a pair of n-type impurity regions (32) formed over the semiconductor film; an insulating film (48) that is interposed between the pair of n-type impurity regions and that is formed over the semiconductor film; and a conductive layer (34, 36) formed over the pair of n-type impurity regions. Wei discloses that the TFT is used in an LCD or imager (col. 1, lines 40-49) but does not disclose the complete invention comprising the pixel electrode. Wei discloses all of the elements of the claims except the pixel electrode electrically connected to the conductive layers. Sasaki et al. shows (fig. 1) an LCD having a pixel electrode (35) connected to conductive layers (48) of a TFT to form the LCD device. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the TFT by electrically connection a pixel electrode to the conductive layers of the TFT as taught by Sasaki to complete the LCD device.

In re claim 14, Wei et al. shows (fig. ) a semiconductor element comprising: a layer comprising titanium (14) formed over a substrate (12); a gate electrode layer (16) formed over the layer comprising titanium; a gate insulating film (28) formed in contact

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with a top surface of the gate electrode layer and a top surface of the layer comprising titanium; a semiconductor film (30) formed over the gate insulating film; a pair of n-type impurity regions (32) formed over the semiconductor film; an insulating film (48) having a thickness of 100 nm (col. 8, lines 37-46) or more (2000 Å = 200 nm > 100 nm) that is interposed between the pair of n-type impurity regions and that is formed over the semiconductor film; and a conductive layer (34, 36) formed over the pair of n-type impurity regions. Wei discloses that the TFT is used in an LCD or imager (col. 1, lines 40-49) but does not disclose the complete invention comprising the pixel electrode. Wei discloses all of the elements of the claims except the pixel electrode electrically connected to the conductive layers. Sasaki et al. shows (fig. 1) an LCD having a pixel electrode (35) connected to conductive layers (48) of a TFT to form the LCD device. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the TFT by electrically connection a pixel electrode to the conductive layers of the TFT as taught by Sasaki to complete the LCD device.

In re claim 15, as far as understood, Wei et al. shows (fig. ) a semiconductor element comprising: a layer comprising titanium (14) formed over a substrate (12); a gate electrode layer (16) formed over the layer comprising titanium; a gate insulating film (28) formed in contact with a top surface of the gate electrode layer and a top surface of the layer comprising titanium; a semiconductor film (30) formed over the gate insulating film; a pair of n-type impurity regions (32) formed over the semiconductor film; an insulating film (48) that is interposed between the pair of n-type impurity regions and

that is formed over the semiconductor film; and a conductive layer (34, 36) formed over the pair of n-type impurity regions, wherein ~~a thickness of a portion of the~~ semiconductor film ~~over which the insulating film is formed is thinner than that of the~~ other semiconductor film, and ~~the semiconductor film over which the insulating film is~~ ~~formed~~ has a thickness of 10 nm or more (col. 7, lines 3-11) ( $2000 \text{ \AA} = 200 \text{ nm} > 10 \text{ nm}$ ). Wei discloses that the TFT is used in an LCD or imager (col. 1, lines 40-49) but does not disclose the complete invention comprising the pixel electrode. Wei discloses all of the elements of the claims except the pixel electrode electrically connected to the conductive layers. Sasaki et al. shows (fig. 1) an LCD having a pixel electrode (35) connected to conductive layers (48) of a TFT to form the LCD device. Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the TFT by electrically connection a pixel electrode to the conductive layers of the TFT as taught by Sasaki to complete the LCD device.

In re claim 16, Wei discloses (col. 8, line 37-46) that the insulating film comprises one of the materials of the group listed in the claims which is polyimide.

In re claim 17, Wei discloses all of the limitations of the claims except the layer comprising titanium oxide. However Sasaki discloses wherein the layer comprises titanium oxide (40b Fig 1). It would have been obvious to one having ordinary skill in the art at the time the invention was made to provide the layer with the specified material, since it has been held to be within the general skill of a worker in the art to select a known material on the basis of its suitability for the intended use as a matter of obvious design choice. [In re Leshin, 125 USPQ 416].

In re claim 18, Wei discloses (col. 1, lines 40-49) wherein the semiconductor element is incorporated in at least one selected from the group consisting of a TV reception set, an electronic book and a cellular phone (since the TFTs of the invention are employed in an LCD display which is used in a TV, electronic book, or cell phone).

***Response to Arguments***

Applicant's arguments with respect to claims 1-6 and 13-18 have been considered but are moot in view of the new ground(s) of rejection.

***Conclusion***

Any inquiry concerning this communication or earlier communications from the examiner should be directed to MATTHEW E. WARREN whose telephone number is (571)272-1737. The examiner can normally be reached on Mon-Thur and alternating Fri 9:00-5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kenneth Parker can be reached on (571) 272-2298. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Matthew E Warren/  
Primary Examiner, Art Unit 2815

March 27, 2009